

# **Notice of References Cited**

Application/Control No.

09/752,099

Applicant(s)/Patent Under  
Reexamination  
CONNOR ET AL.

Examiner

Kim T. Huynh

Art Unit

2189

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## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,567,882	05-2003	Onagawa, Seiki	710/314
*	C	US-5,758,107	05-1998	Robles et al.	710/307
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	L	US-			
	M	US-			

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## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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